9 Statement and signature.

the original document.

Randy W. Tung Name of Person Signing Registration No. 31,311

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of

Total number of pages including cover sheet, attachments, and document : 3

Mail documents to be recorded with required cover sheet information to: Commissioner of Patents & Trademarks, Box Assignments Washington, D.C. 20231

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67,200-336 2000-270

**ASSIGNMENT** 

WHEREAS, we, WEN-TING CHU, DI-SON KUO, JAKE YEH, CHIA-DA HSIEH,

CHUAN-LI CHANG and SHENG-WEI TSAUR, have invented certain improvements in

SACRIFICIAL SELF ALIGNED SPACER LAYER ION IMPLANT MASK METHOD FOR

FORMING A SPLIT GATE FIELD EFFECT TRANSISTOR (FET) DEVICE for which we are

about to make application for Letters Patent of the United States; and

WHEREAS, TAIWAN SEMICONDUCTOR MANUFACTURING CO., LTD. of

No. 121, Park Avenue 3, Science-Based Industrial Park, Hsin-Chu, Taiwan, R.O.C, is desirous of

acquiring the entire right, title and interest in and to said invention;

NOW, THEREFORE, in consideration of One Dollar (\$1.00) and other good and

valuable consideration, the receipt of which is hereby acknowledged, we, WEN-TING CHU, DI-

SON KUO, JAKE YEH, CHIA-DA HSIEH, CHUAN-LI CHANG and SHENG-WEI TSAUR, by

these presents, do hereby sell, assign and transfer unto the said corporation and its assigns, for the

territory of the United States of America and all foreign countries, the entire right, title and interest,

including all priority rights under the International Convention associated with each country of the

Union, in and to said invention as described in the patent application executed by us on the 20th

day of October, 2000, preparatory to obtaining Letters Patent of the United States thereon, and

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in and to said application and any Letters Patent that may be granted in pursuance of said application and any divisional, continuation or continuation-in-part application thereof, and in and to any reissue of any such patent, and in and to any patent applications which may be filed on said invention in countries foreign to the United States and any Letters Patent granted thereon.

We further authorize said corporation to apply for foreign patents on said invention in its own name or through its designees, including subsidiaries, related companies or assignees. under the International Convention or otherwise, and we further agree to execute all papers, including those required for the United States and foreign applications, and to perform such other proper acts as said corporation or its designees the rights herein assigned.

WEN-TING CHU

DI-SON KUO

Chia-Sa Heich

CHIA-DA HSIEH

SHENG-WEI TSAUR

SHENG-WEI TSAUR

TUNG & ASSOCIATES 838 W. Long Lake Road Suite 120 Bloomfield Hills, Michigan 48302

**RECORDED: 01/17/2001** 

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